

Characterization of Silicon Photodetectors (Avalanche Photodiodes in Geiger Mode)

S. Cihangir, G. Mavromanolakis, A. Para.
N.Saoulidou

Factors Affecting Response of a Silicon Photodetector

- Bias voltage (or rather overvoltage, $\Delta V = V - V_{brkd}$)
- Temperature
- Time structure of the light input
- Amplitude of the light input
- Details of the detector construction (geometrical fill factor, cross-talk suppression)
- Others?

Goals

- Develop a complete characteristics of the detector response. Identify relevant variables.
 - For example: is $G(T,V) = G(\Delta V)$, with $V_{brkd} = V_{brkd}(T)$?
- Try to relate some of the characteristics to the detector design and construction
 - For example inter- and intra micro-pixel response uniformity
- Develop algorithm for readout strategy and calibration procedure (integration time, cross-talk, after-pulses, etc..)

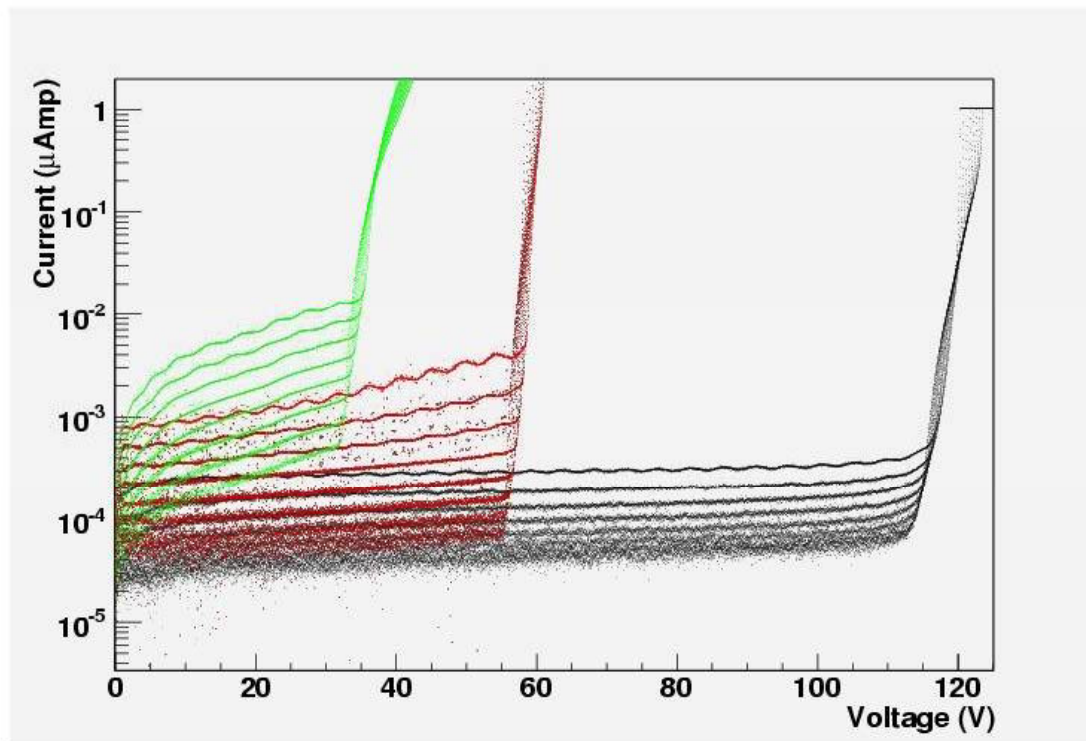
Detector Samples

- Existing
 - Hamamatsu (100, 50 and 25 μ micropixels)
 - IRST (several designs)
 - CPTA
 - Mehti
 - Dubna (two designs)
- Forthcoming
 - SensL
 - Others?

Step 1: Database of Static Characteristics

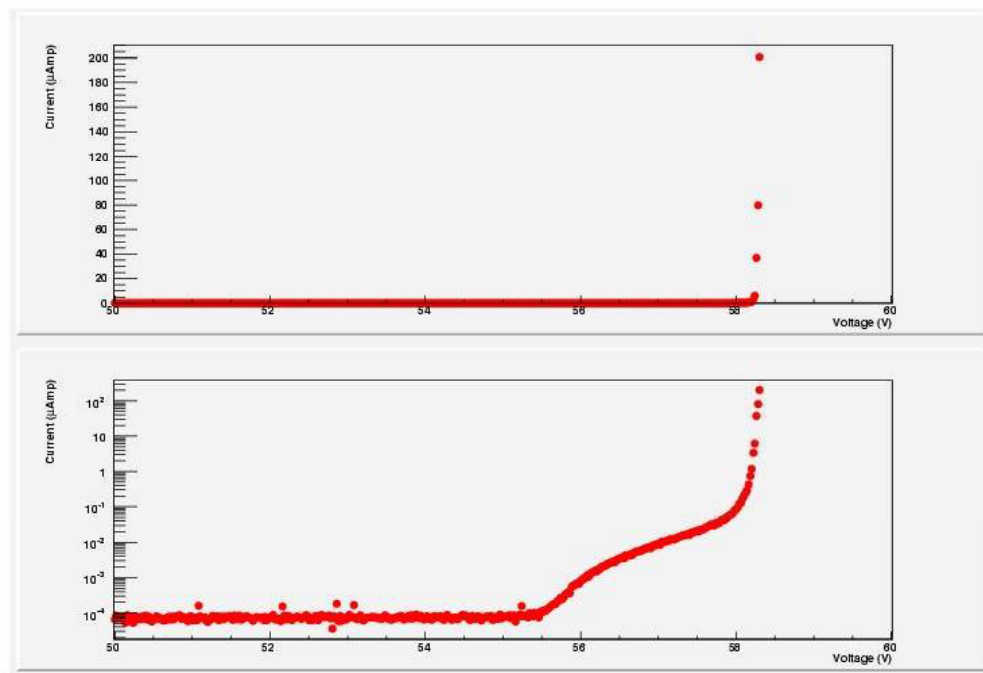
- Develop a procedure for imaging of the detector samples (SiDET facility)
- Develop an automated procedure for static characterization (breakdown voltage, resistance) as a function of the operating temperature
 - Keithley 2400 source-meter
 - Dark box
 - Peltier cold plate
 - Labview controls/readout
- Create a database of the samples, enter the static and image data

I-V Characteristics at Different Temperatures



- Different detectors have quite different operating point
- Dark current and the operating point depend on temperature

Breakdown Voltage: a Knee on the I-V plot?

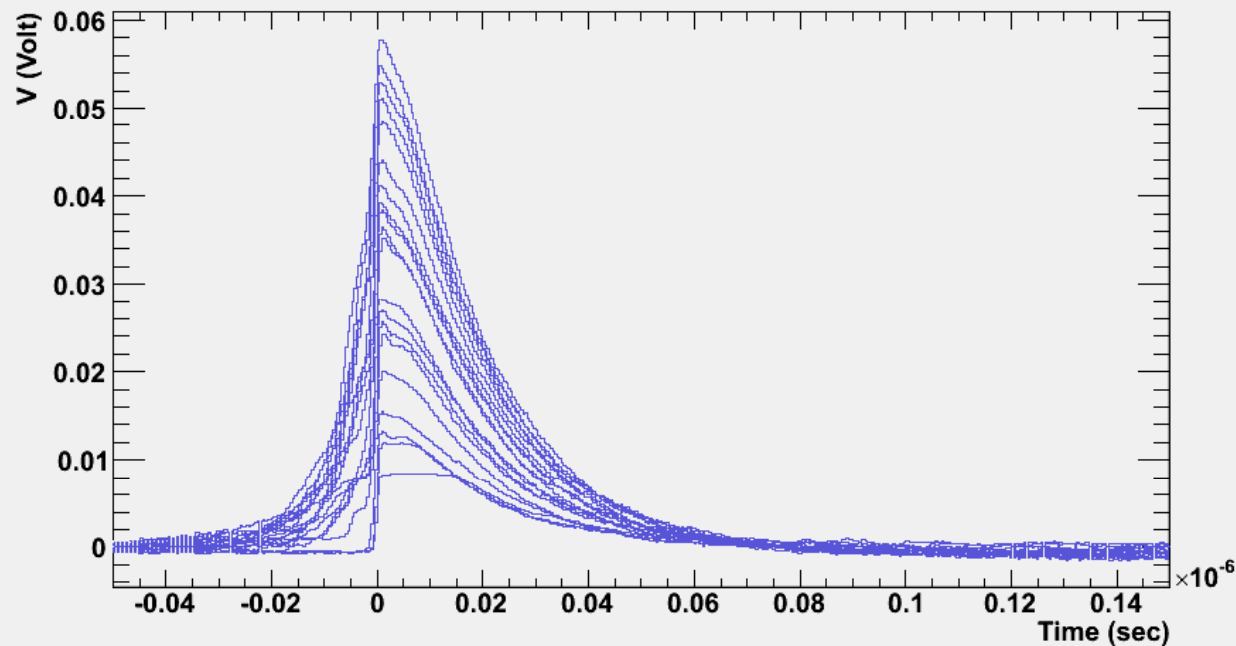


- Linear or logarithmic plot (derivative)?
- What is the shoulder on the IV log plot?
- Different pixels breakdown at different voltages??
- Is it related to the resolution/width of the single electron peak??

Step 2: 'Dark Measurements' (no external light signal)

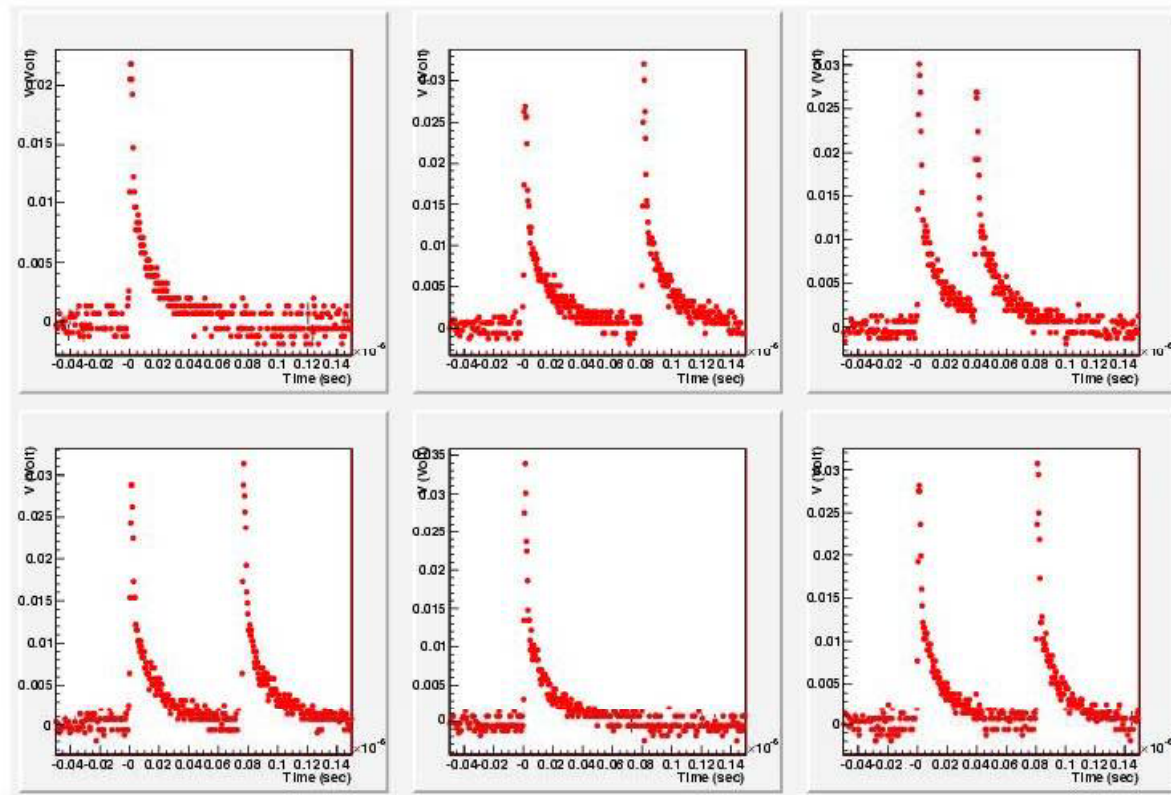
- Readout strategy:
 - Trans-conductance amplifier (MITEQ amplifiers: AU-2A-0159, AU-4A-0150, AM-4A-000110)
 - Controlled temperature:
 - Peltier creates too much of a noise
 - Chiller-based setup under construction
 - Tektronix 3000 series digital scope (5 GHz)
 - LabView DAQ and analysis program
 - Root-based analysis environment
- Dynamical characteristics of the detectors (Later: as a function of the operating temperature).
 - Rate (as a function of threshold, voltage and temperature)
 - Gain = (Charge of a single avalanche)/e (as a function of threshold, voltage and temperature)
- Examples follow (at the 'room' temperature) ...

Average Pulse Shapes for Different Thresholds



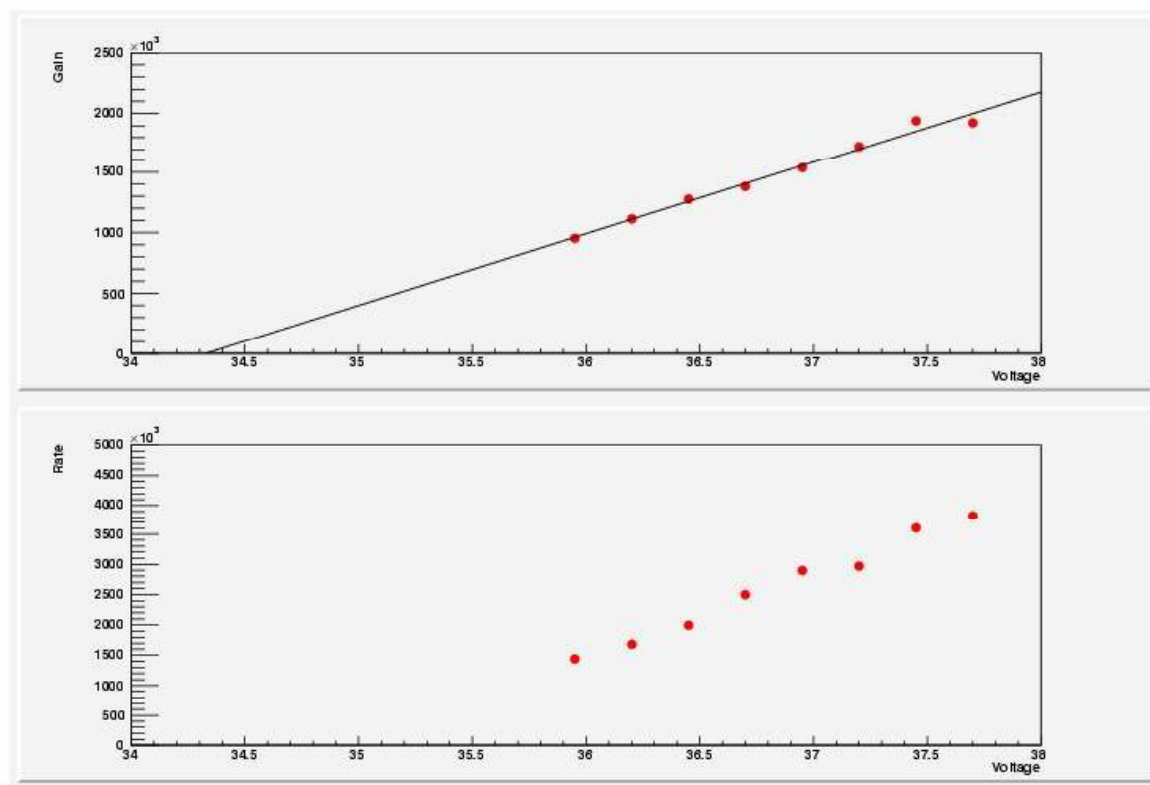
- But... average does not necessarily represent the real pulses

Examples of Real Pulses

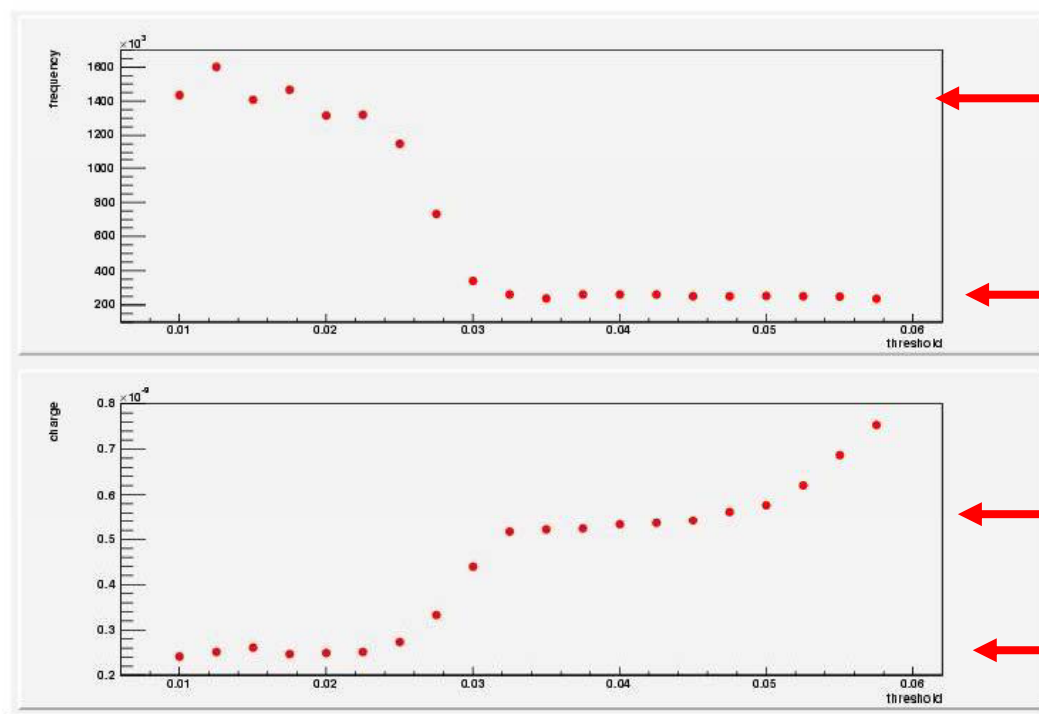


- Afterpulses and/or cross-talk
- $\sim 5-10\%$ (depending on voltage)
- Time constant of tens of nanoseconds

Gain and Rate as a Function of Voltage



Rate and Charge as a Function of Trigger Threshold



Single avalanche

Double avalanche

Double avalanche

Single avalanche

Step 3: Characterization of the Detector Response to a Calibrated Light Pulse

- Light source (under construction):
 - Short pulse duration (<1 nsec)
 - Absolute light calibration (modified scheme of P. Gorodetzky)
 - Variable light intensity (0.1 - 1000 photons)
- Readout and analysis scheme (as before)
- As a function of voltage and temperature:
 - PDE
 - Linearity of the 'prompt' response (~5 nsec gate)
 - The rate, time and amplitude distribution of 'follow-up' pulses (as a function of the light intensity)

Step 4: Microscopic Studies of the Photodetector (Planned)

- Focused (calibrated) light source, 2-3 μ spot size (Selcuk C.)
- Microstage (<1 μ stepping accuracy)
- Dark box containing the detector, focusing lenses and the stage
- Readout as before
- Spatial characteristics of the photodetector, intra and inter-micro pixel variation of:
 - Gain
 - PDE
 - Afterpulses
 - Cross-talk